

FORM PTO-1449
(REV. 7-80)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.
RD-28,667-1

SERIAL NO.

INFORMATION DISCLOSURE STATEMENT BY APPLICANT
LIST OF ITEMSApplicant
Marc SchaepekensFiling Date
11/27/01Group
1763

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A1	6,365,016	4/2/02	Iacovangelo et al.		
	A2	6,397,776	6/4/02	Yang et al.		
	A3					
	A4					
	A5					
	A6					
	A7					
	A8					
	A9					
	A10					
	A11					
	A12					
	A13					
	A14					
	A15					
	A16					

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
	B1					
	B2					
	B3					
	B4					
	B5					

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, etc.)

	C1	PCT Search Report dated October 15, 2003.
	C2	Journal of Non-Crystalline Solids, "Fast Deposition of Microcrystalline Silicon with an Expanding Thermal Plasma", pp. 98-102, 2002.
	C3	Diamond and Related materials, Plasma Chemistry During Deposition of a-C:H", Vollume 11, pp. 989-993, 2002.

EXAMINER

P. Hassanzadeh

DATE CONSIDERED

11-23-04

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant